

# Pulse Heater

Through rapid heating and cooling technology, the Pulse Heater enables fast and repetitive temperature control between RT and 400°C. It plays an essential role in semiconductor packaging processes that require the bonding of semiconductor components or substrates. Due to its fast thermal cycling, energy efficiency, and minimal thermal distortion to surrounding areas, this heater provides improvement of overall process quality and yield.

|                     |                    |                                  |           |                             |
|---------------------|--------------------|----------------------------------|-----------|-----------------------------|
| <b>Applications</b> | Advanced Packaging | Thermo-Compression Bonding (TCB) | Flip-Chip | High Bandwidth Memory (HBM) |
|---------------------|--------------------|----------------------------------|-----------|-----------------------------|



## Manufacturing Specifications

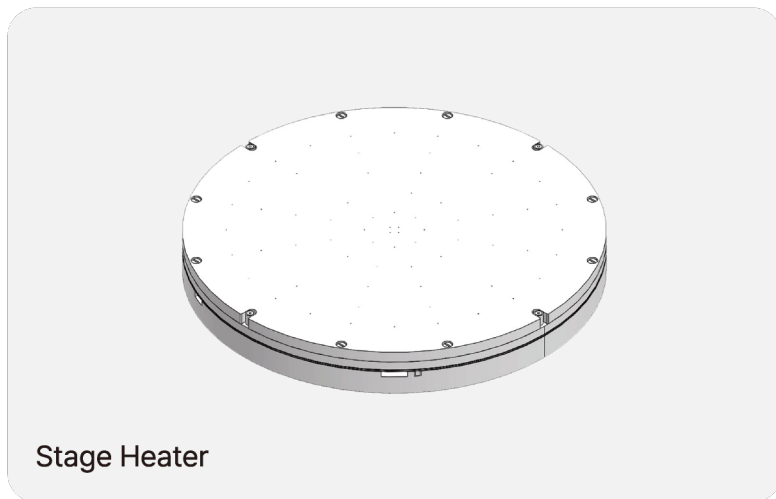
| Inspection Items                        |                    | Specifications                     |
|---|--------------------|------------------------------------|
| Dimension                               | Size               | □16mm                              |
|   | Parallelism        | ~ 5μm                              |
|   | Flatness           | ~ 2μm                              |
| Power Consumption                       | Without Attachment | 160W                               |
|   | With Attachment    | 270W                               |
| Temperature Uniformity                  |                    | Maximum 400.8°C<br>Minimum 399.1°C |
| Service Temperature                     |                    | 400°C                              |
| Heating Rate                            | 100°C → 400°C      | 1.7sec                             |
| Cooling Rate<br>( Air Pressure 0.5Mpa ) | 400°C → 100°C      | 1.7sec (Without Attachment)        |
|   | (AIN Attachment)   | 4.8sec (With Attachment)           |
| Overshoot                               |                    | Maximum 2°C                        |
| Resistance                              |                    | 7.1Ω                               |

# Stage Heater

Bonding occurs on this heater module within semiconductor packaging equipment. It provides a vacuum function to hold and a heating function to preheat the wafer.

|                     |                    |                                  |           |                             |
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|---------------------|--------------------|----------------------------------|-----------|-----------------------------|

## Manufacturing Specifications



### Operating Temperature

<150°C

### Temperature Uniformity

≤±1%

### Materials

AlN

### Flatness

<2μm

## Advanced Packaging | the future with BOBOO HITECH

With new technologies such as AI, 5G, IoT quickly approaching, the demand for high-performance semiconductor devices is soaring high. Advanced Packaging refers to innovative technology that goes beyond conventional packaging techniques, enhancing the performance, power efficiency, and miniaturization of semiconductor chips. As the demand for smaller, more powerful, and more efficient semiconductor chips grows, advanced packaging plays a crucial role in overcoming the limits of Moore's Law and traditional transistor scaling.